

Electronic Acknowledgement Receipt

EFS ID:	1316136
Application Number:	10696882
International Application Number:	
Confirmation Number:	9126
Title of Invention:	Method for depositing a material on a substrate wafer
First Named Inventor/Applicant Name:	Stefan Bader
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Filer Authorized By:	Thomas Langer
Attorney Docket Number:	5367-47
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Application Type:	Utility

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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	NPL Documents	20061115170332.pdf	201428	no	5

Warnings:

Information:

Total Files Size (in bytes):	201428
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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.